



Attorney's Docket

J006 / 881D5/CMP

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ilya Perlov et al.
Serial No. : 09/507,172
Filed : February 18, 2000
Title : CHEMICAL MECHANICAL POLISHING SYSTEM HAVING MULTIPLE
POLISHING STATIONS AND PROVIDING RELATIVE LINEAR MOTION

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the action mailed May 22, 2001, applicant elects the invention of Group I, drawn to an apparatus (claims 1-11, 19-26, 29-31 and 36-37). The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

RECEIVED

JAN 28 2002

Date: 12/11/01

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

December 11, 2002
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